| L Number | Hits | Search Text | DB | Time stamp |
|---|---|---|---|---|
| 1 | 872 | ((charged adj particle adj beam) or CPB) and defect | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/01/27 14:26 |
| 2 | 0 | (((charged adj particle adj beam) or CPB) and defect) and (stencil adj structure) | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/01/27 14:26 |
| 3 | 78 | (((charged adj particle adj beam) or CPB) and defect) and stencil | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/01/27 14:26 |
| 4 | 19 | ((((charged adj particle adj beam) or CPB) and defect) and stencil ) and sample | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/01/27 14:27 |
| 5 | 14 | (((((charged adj particle adj beam) or CPB) and defect) and stencil ) and sample) and (etching or etched) | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/01/27 14:28 |